

Notice of References Cited	Application/Control No. 10/797,153	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Kang Hu	Art Unit 3709	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0039204 a1	11-2001	Tanskanen, Erkki	463/17
*	B	US-2002/0151344 a1	10-2002	Tanskanen, Erkki	463/17
*	C	US-2004/0039655 a1	02-2004	Chau et al.	705/26
*	D	US-2003/0065805 a1	04-2003	Barnes, Melvin L. JR.	709/231
*	E	US-2003/0220835 a1	11-2003	Barnes, Melvin L. JR.	705/14
*	F	US-2006/0173781 a1	08-2006	Donner, Irah H.	705/050
*	G	US-2006/0173790 a1	08-2006	Park et al.	705/064
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2004062303 A	02-2004	Japan	MIYAMOTO et al.	none
	O	WO02/01417A2	01-2002	WO	La Brie	none
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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